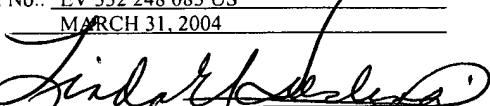




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By:   
LINDA E. HASTINGS

Any fee due as a result of this paper, not covered by an enclosed check, may be charged on Deposit Acct. No. 50-1290.

**Attorney Docket No.: NECK 17.552 (100806-17282)**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Inventor: Hiroshi TANABE  
Serial No.: 09/614,286  
Filed: July 12, 2000  
Title: **METHOD FOR FORMING SEMICONDUCTOR FILMS  
AT DESIRED POSITIONS ON A SUBSTRATE**  
Examiner: Erik J. Kielin  
Group Art Unit: 2813

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

**PETITION FOR EXTENSION OF TIME**

SIR:

Applicant requests that the time for taking action in this case be extended pursuant to 37 CFR 1.136(a) for:

- [ ] one month      **[X] three months**  
[ ] two months      [ ] four months

The fee set in 37 CFR 1.17 for the extension of time is \$950.00.

04/02/2004 AWONDAF1 00000076 501290 09614286

02 FC:1253 950.00 DA

11110642.02

Fee enclosed. Please charge any additional fee required for this extension of time to Deposit Account No. 50-1290. A duplicate copy of this paper is enclosed.

**Charge fee to Deposit Account No. 50-1290. A duplicate copy of this paper is enclosed.**

Applicant is a small entity entitled to pay reduced fees in this application. A verified small entity statement:

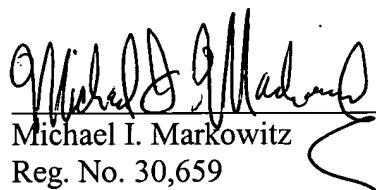
has been filed       is enclosed

Also enclosed is a:

**Response to Official Action**

Notice of Appeal       Appeal Brief

Respectfully submitted,

  
\_\_\_\_\_  
Michael I. Markowitz  
Reg. No. 30,659

**CUSTOMER NO.: 026304**

Phone No.: (212) 940-8687

Fax No.: (212) 940-8986/7

ATTORNEY DOCKET NO.:NECK 17.552

MIM:lh